Supporting Information

Optogenetics-inspired manipulation of synaptic memory using All-Optically Controlled memristors

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Fig. S1 The thickness of Cs₂AgBiBr₆ thin film.



Fig. S2 Fitting result curve of current decay region in Fig. 2b (a) and Fig. 2c (b) after light was turned off.

The stretched exponential function used for fitting the attenuation region. $I=I_0 * exp(-(t/\tau)^{\beta}) + I_C$ (1) Where I₀ is a prefactor and I_c represents the background current, about 0.52nA. τ and β represent the characteristic decay time constant and the stretch index, respectively.



Fig. S3 The variation of PPF and PPD index with the interval of light pulse pairs (Δt).

The fitting function:

 $y = y_0 + A^* exp(-\Delta t/\tau) \tag{2}$

where A and τ are the initial facilitation magnitude and the characteristic relaxation time of the decay term, respectively.



Fig. S4 Current maps measured from the array after being illuminated by green lights, showing patterns of digits "1", "2"and "3".



Fig. S5 The recognition accuracy of the three digits identified by the artificial neural network after the array was processed by and green-red (a) and green light (b).

Device structure	Mechanisms	Wavelength	Photocurrent	Ref.
Bi ₂ O ₂ Se/Graphene	The coexistence of photoconductive and bolometric effects; light- induced physical gas desorption and adsorption.	365nm; 635nm	~1-10µA	1
Ni/MAPbBr ₃ -ZnO/Ni	The increase and diffusion of photogenerated charge carriers.	365nm; 520nm	~0.1-10µA	2
Pyr-GDY/Gr/PbS	The strong photogating effect induced by Pyr-GDY and PbS QDs.	450nm; 980nm	~1-10µA	3
Au/Black Phosphorus/Au	The electron–hole pair generation after UV absorption; Oxygen adsorption on BP surface.	280nm; 365nm	~1-10µA	4
Au/Cs ₂ AgBiBr ₆ /Au	The electron detrapping and trapping in the defects.	405nm; 532nm; 660nm	<1nA	This work

Table. S1 Comparison between previously reported all-optical controlled memristors and this work.

References:

1. C. M. Yang, T. C. Chen, D. Verma, L. J. Li, B. Liu, W. H. Chang and C. S. Lai, *Adv. Funct. Mater.*, 2020, **30**, 2001598.

2. S. Ge, F. Huang, J. He, Z. Xu, Z. Sun, X. Han, C. Wang, L. B. Huang and C. Pan, *Adv. Optical Mater.*, 2022, **10**, 2200409.

3. Y. X. Hou, Y. Li, Z. C. Zhang, J. Q. Li, D. H. Qi, X. D. Chen, J. J. Wang, B. W. Yao, M. X. Yu,

T. B. Lu and J. Zhang, ACS Nano, 2021, 15, 1497-1508.

4. T. Ahmed, S. Kuriakose, E. L. H. Mayes, R. Ramanathan, V. Bansal, M. Bhaskaran, S. Sriram and S. Walia, *Small*, 2019, **15**, e1900966.